



AF/1752  
Zhu

In re application of :  
Takanobu TAKEDA et al. : Group Art Unit.: 1752  
Serial No.: 10/085,935 : Examiner: LEE, Sin J.  
Filed: March 1, 2002 :  
Title: SILICON-CONTAINING POLYMER, RESIST COMPOSITION AND  
PATTERNING PROCESS

**REPLY**

Mail Stop: After Final  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SIR:

In response to the Office Action dated April 21, 2004, please amend the claims as follows and consider the remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 15 of this paper.

**CERTIFICATION OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Services as First Class Mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on: July 21, 2004

Name:

Sharon McDaniel

Signature:

MILLEN, WHITE, ZELANO & BRANIGAN, P.C.

Please  
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SJL

8-12-04